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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shunpei Yamazaki et al.      Art Unit : 2815  
Serial No. : 10/693,491      Examiner : Paul E. Brock II  
Filed : October 27, 2003  
Title : SEMICONDUCTOR DEVICE AND FABRICATION METHOD THEREOF

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450


INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form. Copies of any listed U.S. patents or U.S. patent application publications can be provided upon request.

This statement is being filed after a first Office action on the merits, but before receipt of a final Office action or a Notice of Allowance. A check for \$180 in payment of the late submission fee of \$1.17(p) is enclosed. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 4/15/05

  
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(Modified)U.S. Department of Commerce  
Patent and Trademark OfficeAttorney's Docket No.  
12732-097002Application No.  
10/693,491**Information Disclosure Statement  
by Applicant**

(Use several sheets if necessary)

(37 CFR §1.98(b))

Applicant  
Shunpei Yamazaki et al.Filing Date  
October 27, 2003Group Art Unit  
2815**U.S. Patent Documents**

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	2001-0025960	10/04/2001	Ohtani et al.			05/17/2001
	AB	2004-0051142	03/18/2004	Yamazaki et al.			08/14/2003
	AC	2005-0017242	01/27/2005	Yamazaki et al.			08/17/2004
	AD	2005-0051773	03/10/2005	Nakajima			09/21/2004
	AE	6,259,138	07/10/2001	Ohtani et al.			12/16/1999
	AF	6,545,359	04/08/2003	Ohtani et al.			12/16/1999
	AG	6,617,644	09/09/2003	Yamazaki et al.			11/03/1999
	AH	6,809,021	10/26/2004	Ohtani et al.			02/03/2003
	AI						
	AJ						
	AK						

**Foreign Patent Documents or Published Foreign Patent Applications**

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

**Other Documents (include Author, Title, Date, and Place of Publication)**

Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

Examiner Signature

Date Considered

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.